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CONFIRMATION NO. 3812

SERIAL NUMBER 10/663,642	FILING OR 371(c) DATE 09/17/2003 RULE	CLASS 438	GROUP ART UNIT 2812	ATTORNEY DOCKET NO. 56937-086
APPLICANTS Kiyohito Mukai, Osaka, JAPAN; Tadashi Tanimoto, Shiga, JAPAN; Mitsumi Ito, Kyoto, JAPAN;				
** CONTINUING DATA ***** <i>None will</i>				
** FOREIGN APPLICATIONS ***** JAPAN P2002-270068 09/17/2002 <i>will</i>				
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/22/2004				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>will</i> Acknowledged Examiner's Signature _____ Initials _____	STATE OR COUNTRY JAPAN	SHEETS DRAWING 16	TOTAL CLAIMS 12	INDEPENDENT CLAIMS 4
ADDRESS McDERMOTT, WILL & EMERY 600 13th Street, N.W. Washington, DC 20005-3096				
TITLE Method of fabricating a semiconductor device and a method of generating a mask pattern				
FILING FEE RECEIVED 918	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			
<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit				